

Version AJF/2

EGT3
ENGINEERING TRIPOS PART IIB

Friday 02 May 2014 2 to 3.30

Module 4M6

MATERIALS AND PROCESSES FOR MICROSYSTEMS (MEMS)

NUMERICAL ANSWERS

- 1 (b) (i) 275 mg
 (ii) 128.6 nm
- 2 (b) 870 μm